

**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800**

Attorney's Docket No.: 51876.P507

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Please Enter 3/24/07 QW Do Not
In re Application for:

Sung-Kwon Lee, et al.

Serial No.: 10/750,001

Filed: December 30, 2003

For: **METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE**

Examiner: Quovaunda Jefferson

Art Group: 2823

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Ma'am:

In response to the Final Office Action dated January 26, 2007, please amend and the above-captioned application as set forth below.

Amendments to the Claims are reflected in the Listing of Claims and begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.